

DEC 02 2009

H0027362/9930/95675  
PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/552,497  
Applicant : Neils Richard Hansen  
Filed : September 8, 2006  
TC/A.U. : 1792  
Examiner : Binh X. Tran  
Docket No. : H0027362/9930/95675  
Customer No. : 00128  
Title : METHOD OF  
MANUFACTURING GAS  
DIFFUSION ELECTRODES

Confirmation No.: 2271

**CERTIFICATE OF MAILING BY  
FIRST CLASS MAIL (37 CFR 1.8)**

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**FILED VIA U.S. PTO EFS**

Date: December 1, 2009

**AMENDMENT UNDER RULE 37 CFR § 1.112**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

In conjunction with an Examiner Interview of December 1, 2009, the Applicant responds  
as follows: